



PATENT
Customer No. 22,852
Attorney Docket No. 08245.0027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Jun Dong KIM et al.) Group Art Unit: 2814
)
Application No.: 09/892,878) Examiner: Shrinivas H. Rao
)
Filed: June 28, 2001)
)
For: METHOD FOR FORMING GATE)
ELECTRODES IN A)
SEMICONDUCTOR DEVICE)
USING FORMED FINE)
PATTERNS)

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed July 28, 2003, the period for response having been extended to December 28, 2003 by a request for extension of two months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment sections of this paper.

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